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Docket No.: 4733 USA/W-C/W-C/JB1

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Steven Verhaverbeke et al.) Examiner: Markoff, Alexander
)
Application No: 09/892,130) Art Unit: 1746
)
Filed: June 25, 2001)
)

For: ASSISTED RINSING IN A SINGLE)
WAFER CLEANING PROCESS)

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.312
(Amendment After Allowance)

Sir:

In Response to the Notice of Allowance mailed on December 3, 2004, the
Applicant respectfully requests the Examiner to enter the following amendment.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP _____
COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450
U.S. Patent and Trademark Office, Washington, D.C. 20231 on January 20, 2005

Date of Deposit

Teresa Mattox

Name of Person Mailing Correspondence

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Signature

January 20, 2005
Date